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Attorney's Docket No. 5649-1121

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Seo et al.
Serial No.: 10/620,995
Filed: July 16, 2003
For: METHODS OF FORMING ALUMINUM STRUCTURES IN MICROELECTRONIC

Group Art Unit: 2812
Examiner: To Be Assigned
Confirmation No.: 8840

ARTICLES AND ARTICLES FABRICATED THEREBY

Date: May 24, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

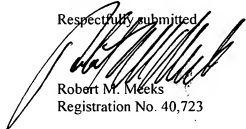
INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a Form PTO-1449 listing documents cited in the Notice to File Response to a Rejection for corresponding Korean Application Number 2002-50491. Each document listed on the attached PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of any listed foreign patent document and/or non-patent literature including the Search Report, is enclosed. A copy of any listed U.S. patent and/or U.S. patent application publication is not provided herewith in accordance with the waiver by the U.S. Patent and Trademark Office of requirements under 37 C.F.R. § 1.98(a)(2)(i) for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 USC § 371 after June 30, 2003.

No fee is believed due; however, the Commissioner is hereby authorized to charge any deficiency or credit any refund to Deposit Account No. 50-0220.

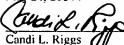
Respectfully submitted,


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